

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: TESHIMA	Atty. Dkt.: 01-279-CON
Serial No.:	Art Unit:
Filed: Concurrently Herewith	Examiner:
Title: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE	

Commissioner for Patents  
U.S. Patent and Trademark Office  
2011 South Clark Place  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Date: February 27, 2004

**PRELIMINARY AMENDMENT**

Sir:

Prior to examination of the above referenced application, please amend the application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 3 of this paper.

**Remarks** begin on page 4 of this paper.